

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Athavale et al.

Examiner: Deo, Duy Vu Nguyen

Serial No: 09/757,123

Group Art Unit: 1765

Filed: January 9, 2001

Docket: 01 P7408 US 02 (8055-142)

For: **METHOD FOR DRY ETCHING DEEP TRENCHES IN A SUBSTRATE**

Mail Stop: Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA. 33212-1450

AMENDMENT

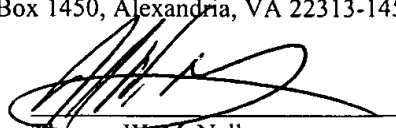
This is a response to the Office Action mailed on September 29, 2003. Please consider the following amendments and remarks to the above-identified application as follows:

02/06/2004 HDAHTE1 00000073 500679 09757123
02 FC:1201 10.00 DA 162.00 DP

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop Fee Amendment, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 29, 2004.

Dated: 29 January 2004


Thomas W. McNally